Annalisa De Pastina

List of Publications by Year in descending order

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1478505 1281871 15 115 11 6 citations h-index g-index papers 15 15 15 113 docs citations times ranked citing authors all docs

#	Article	IF	Citations
1	Quantitative epitope analysis reveals drastic 63% reduced immuno-affinity and 60% enhanced transmissibility for SARS-CoV-2 variants. Nanoscale Advances, 2021, 3, 6903-6911.	4.6	2
2	Avoiding transduction-induced heating in suspended microchannel resonators using piezoelectricity. Microsystems and Nanoengineering, 2021, 7, 34.	7.0	11
3	Rapid Label-free Nanotechnological Immunoassay for Analysis of Candidate Malaria Vaccines. Applied Cell Biology, 2021, 9, .	0.1	2
4	Multimodal real-time frequency tracking of cantilever arrays in liquid environment for biodetection: Comprehensive setup and performance analysis. Review of Scientific Instruments, 2021, 92, 065001.	1.3	8
5	Nanotechnological immunoassay for rapid label-free analysis of candidate malaria vaccines. Nanoscale, 2021, 13, 2338-2349.	5.6	11
6	Mechanics for Fluidics and Bio-Devices. Microtechnology and MEMS, 2020, , 139-196.	0.2	0
7	Fabrication of clamped-clamped beam resonators with embedded fluidic nanochannel. Microelectronic Engineering, 2020, 231, 111395.	2.4	3
8	Suspended micro/nano channel resonators: a review. Journal of Micromechanics and Microengineering, 2020, 30, 043001.	2.6	28
9	Engineered acoustic mismatch for anchor loss control in contour mode resonators. Applied Physics Letters, 2019, 114, .	3.3	10
10	Modular interface and experimental setup for in-vacuum operation of microfluidic devices. Review of Scientific Instruments, 2019, 90, 045006.	1.3	5
11	Effect of AlN seed layer on crystallographic characterization of piezoelectric AlN. Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films, 2019, 37, .	2.1	7
12	Fabrication of suspended microchannel resonators with integrated piezoelectric transduction. Microelectronic Engineering, 2018, 192, 83-87.	2.4	27
13	Piezoelectric nanoelectromechanical systems., 2017,,.		0
14	Release area confinement in Contour mode resonators. , 2017, , .		1
15	Release area confinement in contour mode resonators. , 2017, , .		O